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RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 1763

PATENT APPLICATION  
Doc. No. 5204-022  
Client Ref. No. PCT134US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Young Suk LEE, Young Mopk KANG and Sang Do LEE

Serial No. 09/914,306

Examiner: Crowell, Anna M

Confirmation No. 2394

Filed: July 16, 2002

Group Art Unit: 1763

For: PLASMA PROCESSING APPARATUS AND METHOD FOR  
FORMING THIN FILMS USING THE SAME

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116**

Responsive to the Final Office Action dated April 27, 2004, please amend the application as follows.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.